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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Faris , Sadeg M.

) Group Art Unit

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FILING DATE: 10 February 2004

) Examiner

) tbd

FOR: MICRO-NOZZLE, NANO-NOZZLE,

)

MANUFACTURING METHODS

)

THEREFOR, APPLICATIONS

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THEREFOR

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

TRANSMITTAL of NEW PATENT APPLICATION UNDER 37 CFR 1.53

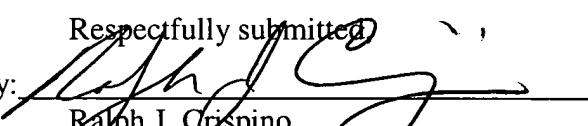
Sir:

Please find enclosed herewith:

- 1) New Patent Application, including:
 - a. Specification (25 pages)
 - b. Claims (10 pages)
 - c. Abstract (1 page)
 - d. Figures (28 sheets)
- 2) Return-Postcard

Respectfully submitted

By:


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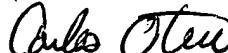
Date: February 10, 2004
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